

Docket No.: 50006-073

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Isao NOJIRI, et al. :
Serial No.: Group Art Unit:
Filed: September 05, 2000 Examiner:
For: SEMICONDUCTOR DEVICE AND ITS WIRING METHOD

#37DS
10/31/00
Suler
JC511 U.S. PTO
09/654875
09/05/00

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

zial No.:

Each non-English language reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.